NANOSECOND TUNABLE LASERS

NT230 • NT242 • NT252 • NT270 • NT340 • NT350 • NT370 PhotoSonus • PhotoSonus X

NT340 SERIES



BENEFITS

- The system is widely tunable 192 – 2600 nm and delivers high pulse energy (up to 60 mJ) that allows the investigation of an extensive range of materials
- Up to 18 µm customization possibility enables studies of IR vibrations of molecules
- Narrow linewidth (down to 3 cm⁻¹) and superior tuning resolution (1 – 2 cm⁻¹) allows recording of high quality spectra
- Flashlamps replacement without misalignment of the laser cavity saves on maintenance costs
- The NT340 series tunable wavelength nanosecond laser seamlessly integrates the nanosecond optical parametric oscillator and the Nd:YAG Q-switched nanosecond laser – all in a compact housing.

The main system features are: hands-free wavelength tuning from UV to IR, high conversion efficiency, optional fiber-coupled output and separate output port for pump laser beam.

NT340 has a linewidth of less than 5 cm⁻¹, which is ideal for many spectroscopic applications.

***EKSPLA**

- High integration level saves valuable space in the laboratory
- In-house design and manufacturing of complete systems, including pump lasers, guarantees on-time warranty and post warranty services and spares supply
- Variety of control interfaces: USB, RS232 and optional LAN, WLAN ensures easy control and integration with other equipment
- Attenuator and fiber coupling options facilitate incorporation of NT340 systems into various experimental environments

The laser is designed for convenient use. It can be controlled from remote keypad or PC using LabView™ drivers that are supplied with the system. The remote keypad features a backlit display that is easy to read even through laser safety googles. The OPO pump energy monitoring system helps to control pump laser parameters. Replacement of laser flashlamps can be done without misalignment of the laser cavity and/or deterioration of laser performance.

High Energy Broadly Tunable Lasers

FEATURES

- Hands-free no gap wavelength tuning from 192 to 4400 nm
- Up to 60 mJ pulse energy in visible spectral range
- Up to 10 mJ pulse energy in UV spectral range
- Up to 15 mJ pulse energy in MIR spectral range
- 3 5 ns pulse duration
- ▶ Up to **20 Hz** pulse repetition rate
- Remote control via key pad or PC
- Optional separate shared output port for 532/1064 nm beam (separate output port for the 355 nm beam is standard)
- OPO pump energy monitoring
- Hermetically sealed oscillator cavity protects non-linear crystals from dust and humidity

APPLICATIONS

- Laser-induced fluorescence
- Flash photolysis
- Photobiology
- Remote sensing
- Time-resolved spectroscopy
- Non-linear spectroscopy
- Vibrational spectroscopy
- Cavity ring-down CRDS, cavity ring-down laser absorption CRLAS spectroscopy
- Infrared spectroscopy
- ► Gas spectroscopy

Picosecond Lasers



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NT340 SERIES

Tuning range extending optional add-ons

Option	Features	
-SH	Second harmonic generator for 210–410 nm range	
-SF	Sum-frequency generator for 300-410 nm range with high pulse energy	
-SH/SF	Combined option for highest pulse energy in 210–410 nm range	
-DUV	Deep UV option for 192–210 nm range output	
-MIR	Mid infrared option for 2500–4400 nm range output	

Accessories and other optional add-ons

Option	Features	
-FC	Fiber coupled output in 350–2000 nm range	
-ATTN	Attenuator	
-H, -2H	Separate shared output port for pump laser harmonic (532 or 1064 nm wavelengths)	
-AW	Air cooled power supply	

SPECIFICATIONS ¹⁾

Model	NT342B	NT342C	
ОРО			
Wavelength range ²⁾			
Signal	410-71	10 nm ³⁾	
ldler	710–2600 nm		
SH generator (optional)	210-410 nm		
SH/SF generator (optional)	210–410 nm		
DUV generator (optional)	192-2	192–210 nm	
MIR generator (optional)	2500-4	2500-4400 nm	
Output pulse energy			
OPO ⁴⁾	30 mJ	60 mJ	
SH generator (optional) ⁵⁾	4 mJ	6.5 mJ	
SH/SF generator (optional) ⁶⁾	6 mJ	10 mJ	
DUV generator (optional) ⁷⁾	0.6 mJ	1 mJ	
MIR generator (optional) ⁸⁾	15 mJ		
Linewidth	< 5 cm ⁻¹ 9)		
Tuning resolution ¹⁰⁾			
Signal (410–710 nm)	1 cm ⁻¹		
ldler (710–2600 nm)	1 cm ⁻¹		
SH/SF/DUV (192–410 nm)	2 cm ⁻¹		
MIR (2500–4400 nm)	1 cm ⁻¹		
Pulse duration ¹¹⁾	3–5 ns		
Typical beam diameter ¹²⁾	5 mm	7 mm	
Typical beam divergence ¹³⁾	< 2 mrad		
Polarization			
Signal	horizontal		
Idler	vertical		
SH/SF	horizontal		
DUV	vertical		
MIR	horizontal		

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NT340 SERIES

SPECIFICATIONS ¹⁾

Model		NT342B	NT342C
PUMP LASER ¹⁴⁾			
Pump wavelength			355 nm
Typical pump pulse energy		100 mJ	150 mJ
Pulse duration			4–7 ns
Beam quality		Hat-top in near field, without hot spots	
Beam divergence		< 0.6 mrad	
Pulse energy stability (StdDev)		<3.5 %	
Pulse repetition rate		10 or 20 Hz	10 Hz
PHYSICAL CHARACTERISTICS			
Unit size (W × L × H) ^{15}		456 × 821 × 270 mm	
Power supply size (W \times L \times H)		330 × 490 × 585 mm	
Umbilical length		2.5 m	
OPERATING REQUIREMENTS			
Water consumption (max 20 °C) ¹⁶⁾		< 10 l/min	
Room temperature		18–27 °C	
Relative humidity		20-80 % (non-condensing)	
Power requirements		200 – 240 VAC, single phase, 50/60 Hz	
Power consumption		< 1.5 kVA	
Cleanness of the room		not worse than ISO Class 9	
 Due to continuous improvement, all specifications are subject to change. Parameters marked typical are illustrative; they are indications of typical performance and will vary with each unit we manufacture. Unless stated otherwise, all specifications are measured at 450 nm and for basic system without options. Hands-free tuning range is from 192 nm to 4400 nm. MIR option is not compatible with SF and DUV option. Inquire for custom IR option with tuning up to 18 µm. Tuning range extension to 400 – 709 nm is optional. Measured at 430 nm. See tuning curves for typical outputs at other wavelengths. Measured at 240 nm. SF generator is optimized for maximum output in 300 – 410 nm range. See tuning curves for typical outputs at other wavelengths. Measured at 340 nm. SF generator is optimized for maximum output in 300 – 410 nm range. See tuning curves for typical outputs at other wavelengths. Measured at 200 nm. See tuning curves for typical outputs at other wavelengths. 	 2500 – 4400 10) When wave wavelength resolution i: MIR and 0.0 10) FWHM mea 1 ns rise tim oscilloscope 12) Beam diam FWHM leve depending wavelength 13) Full angle n 450 nm, < 1 14) Separate or standard. C beams are i optimised fi specification manufactur 	eter is measured at 450 nm at the I. It is approximate and can vary on the pump pulse energy and measured at the FWHM level at 5 mrad at 3000 nm with MIR option. Itput port for the 355 nm beam is utputs for 1064 nm and 532 nm optional. Laser output will be or the best OPO operation and is may vary with each unit we e. at 821 to 1220 mm depending on	<image/>
 typical outputs at other wavelengths. Measured at 3000 nm. See tuning curves for typical outputs at other wavelengths. 	¹⁶⁾ Air cooled µ option.	power supply is available as an	<i>Fig 1</i> . NT340 series laser typical beam profile at 450 nm after ~1.5 m distance from output

Other Ekspla Products



NT340 SERIES

PERFORMANCE

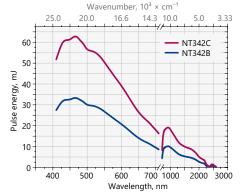


Fig 2. Typical output energy of the NT340 series tunable wavelength systems

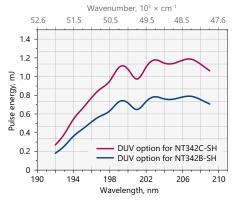


Fig 4. Typical output energy of the NT340 series tunable wavelength systems with SH/DUV extension

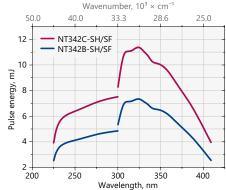


Fig 3. Typical output energy of the NT340 series tunable wavelength systems with SH/SF extension

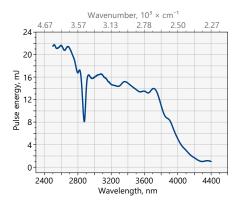
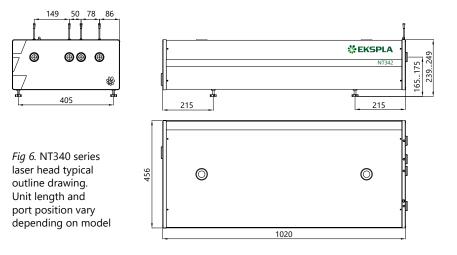


Fig 5. Typical output energy of the NT340 series tunable wavelength systems with MIR extension

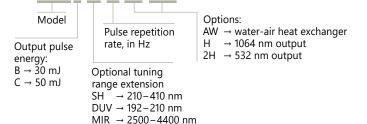
OUTLINE DRAWINGS



ORDERING INFORMATION

Note: Laser must be connected to the mains electricity all the time. If there will be no mains electricity for longer that 1 hour then laser (system) needs warm up for a few hours before switching on.







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